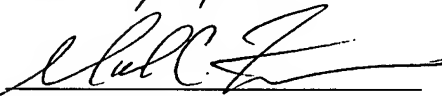




1-7-05

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

U.S. Serial No. 10/749,650 ) I hereby certify that this paper (and/or fee)  
Applicants: Park ) is being deposited with the United States  
Title: Methods of Forming Metal ) Postal Service as first class mail in an  
Lines in Semiconductor Devices ) envelope addressed to:  
Filed: December 30, 2003 ) Mail Stop Amendment  
TC/AU: 2891 ) Commissioner for Patents  
Examiner: Lee, Granvill ) P.O. Box 1450  
Docket No.: ) Alexandria, VA 22313-1450  
20067/OPP031479US ) on this date:  
 ) Dated: 7/14/2005  
 )   
 ) Mark C. Zimmerman  
 ) Registration No. 44,006

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO THE OFFICE ACTION DATED APRIL 15, 2005

Dear Sir:

Please enter the following amendments and consider the following remarks.

**The Status of the Claims** is reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.